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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Sreenivasan et al.
App. No.: 10/614,716 GPAU: 1722
Filing Date: 07/07/2003 Examiner: Donald Heckenberg
Dkt. No.: P90-32V30 Conf. No.: 7603
For: CONFORMING TEMPLATE FOR PATTERNING LIQUIDS DISPOSED ON
SUBSTRATES

INFORMATION DISCLOSURE STATEMENT

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following information is submitted in compliance with Applicants' duty of disclosure and pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98. The undersigned brings the patents, publications, applications or other information identified in the attached:

☒ Form(s) PTO/SB/08A and/or PTO/SB/08B or PTO/1449

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to the Examiner's attention in the above-identified application. It is respectfully requested that the cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed:

before the mailing date of a first Office action on the merits or before the mailing date of a first Office action after the filing of a request for continued examination under § 1.114. Therefore, no fee is believed required.

Applicants do not believe that any additional fees are due, but if the Commissioner believes additional fees are due, the

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Signed: Katrina Prati

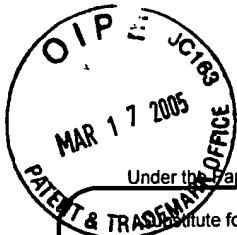
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Respectfully Submitted,



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| | |
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| Application Number | 10/614,716 |
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| First Named Inventor | Sreenivasan et al. |
| Art Unit | 1732 |
| Examiner Name | Unassigned |
| Attorney Docket Number | P90-32V30 |

U. S. PATENT DOCUMENTS

| Examiner Initials* | Cite No. ¹ | Document Number | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
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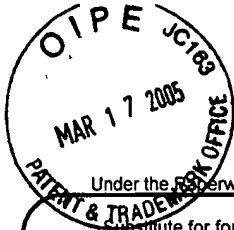
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Application Number 10/614,716

Filing Date 07/07/2003

First Named Inventor Sreenivasan et al.

Art Unit 1732

Examiner Name Unassigned

Attorney Docket Number P90-32V30

Sheet 3

of

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NON PATENT LITERATURE DOCUMENTS

| Examiner Initials* | Cite No. ¹ | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T ² |
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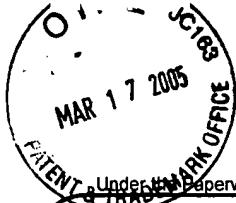
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|-----------------------|--------------------------|---|----------------|
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